05.1-71 INFLUENCE OF MAGNETIC FIELDS ON THE HALFINTEGER BRAGG REFLECTIONS IN MAGNETITE. By T. Nakajima, S. Suzuki*, K. Namikawa*, S. Todo ${ }^{* *}$, K. Chiba ${ }^{+}$, M. Ando and S. Chikazumi ${ }^{++}$. National Laboratory for High Energy Physics, Oho, Tsukuba, Ibaraki 305, * Faculty of Science, Tokyo Institute of Technology, Meguro, Tokyo 152, ** The Institute far Solid State Physics, Roppongi, Tokyo $106,+$ Chiba Institute of Technology, Tsudanuma, Narashino 275, + Faculty of Engineering, Keio University, Hiyoshi, Yokohama 223

The organizing process of charge ordering associated with the internal lattice deformations due to the simultaneous condensation of a few phonon mode remains unsolved now, since studies on the Verwey transition of magnetite at about $120 \mathrm{~K}\left(\sim_{\mathrm{T}}\right)$ by electron diffraction
(1) and neutron diffraction (2) induce doubt on the validity of the transition scheme as originally proposed by Verwey (3). In connection with this subject, the field dependence of half-integer reflexions (441/2) and ( $441 / 2$ ) resulting from $\Delta_{5}$ mode distortions was
investigated by intensity measurements and rapid $X$-ray topography with use of white SR X -ray in KEK. The crystal used here is a (110) triangle shape plate of several millimeter and $174 \mu \mathrm{~m}$ in thickness. Transmission Laue patterns for hhl series were observed (Fig.1). All spots were indexed by comparing them with computer generated pattern. In order to orientate and retain the monoclinic c-axis, this was field-cooled through $T$ under 2.3 k 0 e being off by $50^{\circ}$ from [001] direction in view of the magnetocrystalline anisotropy. The intensity of the half-integer reflexions measured by a solid state detector varies with the change of magnetic fields up to 2.3 k 0 e . However, its variation remains to be systematically understood. A very faint Bragg reflexion ( $44 \overline{1}$ ) was detected at least below 66 K which should be attributed to one of several X -mode distortions. This closely relates with the crystal structure below $T_{v}$. In topographic image of the super spot ( $44 \overline{1 / 2}$ ), sharp fine striation patterns parallel to [110] direction were observed. These patterns are observable in (hinl) ( $\ell \neq 0$ ) reflexions. Detailed report will be presented including the results of $X$-ray topography and the extended work.


Fig. 1 hhl series including half integer spots.
(1) T. Yamada, K. Suzuki and S. Chikazumi, Appl. Phys. Letters 13172 (1968), (2) J. Samuelson, E.J. Bleeker, I. Doborzynski and T. Riste, J. Appl. Phys. 391114 (1968), (3) E.J. Verwey and P.W. Haayman, Physiea 8979 (1941) ; E.J. Verwey, P.W. Haayman and F.C. Romeijn, J. Chem. Phys. 15181 (1947)
05.1-72 X-RAY DIFFRACIION STUDY OF THE MECHANISM OF 3C TO 6H TRANSFORMATION IN SIC. By V.K. Kabra*, Dhananjai Pandey* and S.Lele**, *School of Materials Science and Technology, **Department of Metallurgical Engineering, Banaras Hindu University, Varanasi 221005, India.
It is known that single crystals of 30 or ABC ... modification of silicon carbide undergo solid state transformation to the 6 H or ABCACB ... structure when annealed at temperatures above $1600^{\circ} \mathrm{C}$. The transformation commences with a statistical insertion of stacking faults in the 3C-structure giving rise to characteristic diffuse streaks on diffraction patterns. As the transformation proceeds further, new reflections characteristic of the 6 H structure become discernible along the streaked-rows. The present investigation was undertaken to study the mechanism of 3 C to 6 H transformation in SiC by determining the nature and distribution of stacking faults effecting the transformation.

Solid state transformations in Sic can take place either through a non-random insertion of deformation faults resulting from slip of parts of the crystal past each other through partial slip vectors or through a non-random insertion of layer displacement faults involving disruption of normal stacking sequence for a pair of layers leaving distant layers unaffected (Pandey et al. Proc.Roy. Soc. London (1980) A369, 435; ibid 451; ibid 463). The 30 to 6H transformation by the deformation mechanism would require consecutive basal slip through (1/6)〈11"〉 vectors on three successive layers followed by no slip on three subsequent layers as depicted below:


Resulting Structure ( 6 H ): ABCACB, $\mathrm{ABCACB}, \ldots$
The desired basal-slip can take place by the passage of Shockley partials in accordance with the suggestion of ogbuji et al. (J.Am. Cer. Soc. (1981), 64, 91). On the other hand in layer displacement mechanism, the interchange in orientation of a pafr of neighbouring layers as a unit process is required after every four layers of the 3 C structure in a manner depicted below:

Initial Structure $(3 C): ~ A B C A B C A B C A B C$
Resulting Structure $(6 H):-.$.
The displacement of a pair of layers as a unit process can take place by a diffusional rearrangement of atoms. In order to make a choice between the two possibilities, we have developed the theory of diffraction from 3C crystals undergoing transformation to the 6H structure through a non-random insertion of deformation and layer displacement faults separately. From a comparison of the theoretically predicted diffraction effects with those experimentally observed, it is concluded that the 3C to 6 H transformation in SiC takes place by the layer displacement mechanism.

